WEST Search History

Hide Items | Restore | Clear | Cancel

DATE: Friday, August 31, 2007

Hide?, <u>Set</u> <u>Name</u>	Query	<u>Hit</u> Count		
DB=PGPB, USPT; PLUR=YES; OP=OR				
☐ L22	17 and 18 and 19 and 113	5		
L 21	16 and L20	69		
□ L20	113 and 111	80		
□ L19	17 and 18 and 19 and 110	5		
L18	116 and 18	6		
□ L17	115 and L16	5		
□ L16	113 and 17	40		
□ L15	(cd or (critical adj dimension))	372178		
□ 'L14	17 and 111 and L13	1		
□ L13	(mov\$ or resiz\$ or (re adj siz\$) or expand\$ or expansion or shrink\$) with (line or edge or fragment or segment or polygon)	696145		
□ L12	17 and 18 and 19 and 110	5		
	verif\$ with (opc or (optical adj proximity adj correct\$) or ret or (retical adj enhancement adj technique))	323		
□ L10	(opc or (optical adj proximity adj correct\$) or ret or (retical adj enhancement adj technique))	18301		
☐ L9	(statistic\$ or (standard adj deviation))	294211		
L8	(response adj function) or (cd or (critical adj dimension)) or ((2d or (2 adj d) or (2 adj dimension\$)) or (two adj dimension\$)) adj area)	384156		
L7	(virtual adj mask)	109		
L6	L2 or 382/\$[ccls]	139125		
□ · L5	7035446[pn]	1		
口 L4	L2 and L3	43		
□ : L3	post adj (opc or (optical adj proximity adj correct\$))	53		
□ L2	716/\$[ccls] or 430/\$[ccls]	90532		
L 1	(6658640 6421820 6562638)[pn]	3		

END OF SEARCH HISTORY

WEST Search History



DATE: Friday, August 31, 2007

Hide?	<u>Set</u> Name	Query	<u>Hit</u> Count
	DB=PG	SPB; PLUR=YES; OP=OR	
	L18	110 and 111 and 112 and 113 and 114 and 115 and L16	. 0
	L17	110 and 112 and 113 and 114 and 115 and L16	0
Ė.	L16	(response adj function)[clm]	520
	L15	(virtual adj mask)[clm]	9
	L14	(cd or (critical adj dimension))[clm]	8614
	L13	(statistic\$ near5 modif\$)[clm]	128
	L12	(predict\$ near3 distortion)[clm]	51
	L11	(mov\$ with line)[clm]	10032
	L10	(pattern near5 polygon)[clm]	152
	L9	11 and 12 and 13 and 14 and 15 and 16 and 17 and L8	0
	1.8	((manufacturing or fabrication or process\$) near3 (error or violation or defect))[clm]	4659
	L7	reticle[clm]	1755
	L6	sensitivity[clm]	8099
	L5	image[clm]	139839
	L4	wafer[clm]	23222
	L3	mask[clm]	34027
有。	L2	(post adj (opc or (optical proximity correct\$)))[clm]	56
	L1	verif\$[clm]	23132

END OF SEARCH HISTORY